

APPLICANT'S ART CITATION (Use several sheets if necessary)		Application 10/542,276		OFGS File No. P/4745-3			
		Applicant Kyung-Hwa PARK					
		Filing Date July 14, 2005		Group Art Unit			
U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)							
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub- class	Filing Date If Appropriate	
	US-						
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub- class	Translation	
						Yes	No
	JP 06-302425	10-1994	Japan			Abstract	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
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